IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Taku KANAOKA et al.

Appln. No.:

Filed: HEREWITH

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING

THE SAME

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the aboveidentified patent application as indicated below.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.